Search Notes		

Application/Control No.	Applicant(s)/Patent und Reexamination	ler
10/758,276	TAKAHASHI ET AL.	
Examiner	Art Unit	
Shih-wen Hsieh	2861	

	SEARCHED		
Class	Subclass	Date	Examiner
347	22-35	12/21/2005	swh

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOT (INCLUDING SEARCH S	ES STRATEGY)	
	DATE	EXMR
	in .	
		i
	-	
		_